

**REPLY UNDER 37 CFR § 1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER 1600**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kirby *et al.*

Serial No.: 10/804,366

Filed: March 19, 2004

For: METHODS OF SELECTIVELY
REMOVING SILICON (as amended)

Confirmation No.: 9222

Examiner: T. Pham

Group Art Unit: 2813

Attorney Docket No.: 2269-6208US
(03-0852.00/US)

VIA ELECTRONIC FILING
September 10, 2007

**AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE**

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Examiner:

The following amendments and remarks are filed in response to the Examiner's remarks in the Final Office Action mailed July 9, 2007, the three-month shortened statutory period for response to which expires on October 9, 2007. This response is submitted on or before two months from the mailing date of the Final Office Action.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.